

Special Issue

Piezoelectric Materials, Devices, and Integrated Systems: From Fundamentals to Applications

Message from the Guest Editors

All interested researchers are invited to contribute to this Special Issue with their original research articles, communications, and review articles. Manuscripts will be internationally peer-reviewed. Please note that all submitted papers must be within the general scope of the *Micromachines* journal. Topics may include, but are not limited to, the following:

- Novel methods for the preparation of piezoelectric materials;
- Novel modelling and design methods of piezoelectric devices;
- Integrated circuit design for piezoelectric applications;
- Simulation and design methods of 3D-integrated systems;
- Promising applications of piezoelectric materials, devices, and integrated systems.

Guest Editors

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Deadline for manuscript submissions

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About the Journal

Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

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